



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Toshimichi Kurihara, et al.

Examiner: N.O. Berezny

Serial No.: 09/942,445

Group Art Unit: 2813

Filed: Aug. 30, 2001

Docket: 14872

For: SEMICONDUCTOR DEVICE
AND MANUFACTURING METHOD
THEREOF

Dated: May 27, 2003

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

#8/IDS
6/12/03
JG

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

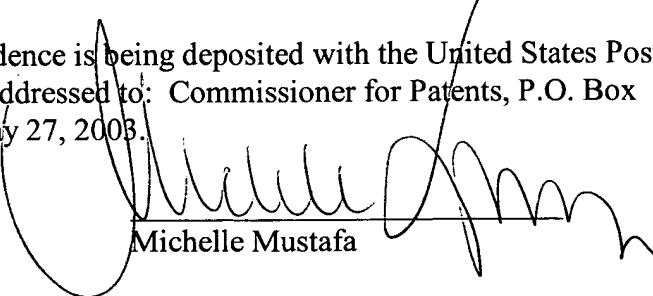
1. U.S. Patent 5,266,739, dated November 30, 1993, issued to Yamauchi; and
2. Taiwanese Patent No. 328156, dated March 11, 1998.

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CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on May 27, 2003.

Dated: May 27, 2003


Michelle Mustafa

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The references were cited in an Official Action dated February 25, 2003, received from the Taiwanese Patent Office. A copy of the Taiwanese Office Action is enclosed. Applicants are submitting copies of the above-cited references, along with a translation of the Examiner's comments regarding the references from the Taiwanese Office Action. The relevance of the references is described in the Official Action.

In compliance with the requirements of 37 C.F.R. § 1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 35 U.S.C. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of portions of an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made; the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

Inasmuch as this Information Disclosure Statement is being submitted in accordance with the schedule set out in 37 C.F.R. § 1.97(d), the petition fee and certification are enclosed.

Respectfully submitted,


Paul J. Esatto, Jr.
Registration No. 30,749

Scully, Scott, Murphy & Presser
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Garden City, New York 11530
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PJE:ahs



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: **Toshimichi Kurihara, et al.** Examiner: **N.O. Berezny**

Serial No.: **09/942,445** Group Art Unit: **2813**

Filed: **Aug. 30, 2001** Docket: **14872**

For: **SEMICONDUCTOR DEVICE
AND MANUFACTURING METHOD
THEREOF** Dated: **May 27, 2003**

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

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**STATEMENT PURSUANT
TO 37 C.F.R. § 1.97(c)(1) and (e)(1)**

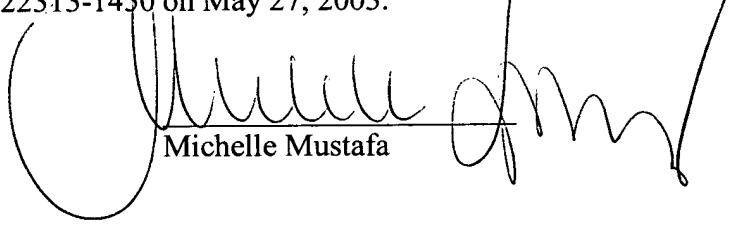
Sir:

I hereby state that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

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Dated: May 27, 2003



Michelle Mustafa

Accordingly, it is respectfully requested that the accompanying Information Disclosure Statement be considered with respect to the above-identified application.

Respectfully submitted,


Paul J. Esatto, Jr.
Registration No. 30,749

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MAY 29 2003

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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
Under 37 CFR 1.97(d))

Docket No.
14872

In Re Application Of: **Toshiyuki Kurihara, et al.**

Serial No.

09/942,445

Filing Date

Aug. 30, 2001

Examiner

N. O. Berezny

Group Art Unit

2813

Title: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Address to:
Commissioner for Patents

The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(c), and on or before payment of the issue fee, and is accompanied by the Statement as specified in 37 CFR 1.97(e) and the fee set forth in 37 CFR 1.17(p).

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A check in the amount of \$180.00 is attached.

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(Date)

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Paul J. Esatto, Jr.
Signature
Paul J. Esatto, Jr., Reg. No. 30,749

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Michelle Mustafa
Signature of Person Mailing Correspondence

Michelle Mustafa
Typed or Printed Name of Person Mailing Certificate

*This certificate may only be used if paying by deposit account.

Dated: May 27, 2003

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cc: